GP284

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Jingyu Lian, et al.

Serial No.:

09/751,551

Filing Date:

December 28, 2000

Art Unit:

2815

Examiner:

Ortiz, Edgardo

Docket No.:

00 P 9119 US

#10/AndtAr Ams 4/9/02

For:

MULTI-LAYER Pt ELECTRODE FOR DRAM AND FRAM

WITH HIGH K DIELECTRIC MATERIALS

## Mailing Certificate Pursuant to 37 C.F.R. § 1.8

I hereby certify that, on or before the undersigned date, the above correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C., 20231.

Joan Korkel

2-12-02

Joan Konkel

Date

**Assistant Commissioner for Patents** 

Washington, D.C. 20231

## RESPONSE PURSUANT TO 37 C.F.R. § 1.111

Dear Sir:

This response is being filed in response to the Office Action mailed December 3, 2001.

Entry of this Amendment is respectfully requested. A marked up version of the claims is included as Appendix 1, and a clean set of claims is provided in Appendix 2, with both Appendices being

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